



Japan PV Automation Committee Meeting Summary and Minutes

PVJapan 2012 6th December 2012, 10:00-12:00 Makuhari Messe, Chiba, Japan

Next Committee Meeting

12th April, 2013, 15:00-18:00 Japan Standard Time Japan Standards Spring Meetings 2013, Tokyo, Japan

Committee Announcements (optional)

None

Table 1 Meeting Attendees

Co-Chairs: Terry Asakawa (TEL), Makoto Ishikawa (Nisshinbo Mechatronics), Emi Ishikawa (Atelier Ishikawa)

SEMI Staff: Hirofumi Kanno

Company	Last	First	Company	Last	First
Nisshinbo Mechatronics	Ishikawa	Makoto	Atelier Ishikawa	Ishikawa	Emi
TEL	Asakawa	Terry	TEL	Murakami	Takashi
TEL	Murata	Naoko		•	•

Table 2 Leadership Changes

Group	Previous Leader	New Leader
GCS Voters of Japan PV Automation Committee	Terry Asakawa (TEL)	Terry Asakawa (TEL) remains as a GCS Voter
	` ,	Makoto Ishikawa (Nisshinbo Mechatronics

Table 3 Ballot Results (or move to Section 4, Ballot Review)

Passed ballots and line items will be submitted to the ISC Audit & Review Subcommittee for procedural review.

Failed ballots and line items were returned to the originating task forces for re-work and re-balloting.

	8 8	
Document #	Document Title	Committee Action
None		

Table 4 Authorized Ballots (or move to Section 7, New Business)

#	When	SC/TF/WG	Details
5223	Cycle 2-	PC Equipment	New Subordinate Standard: Media Interface Specifications for a Horizontal
	2013	I/F Specification	Communication between Equipment for Larger Sized Substrate Oriented Photovoltaic
		Task Force	Fabrication System to Doc.4804 "Specification for a Horizontal Communication between
			Equipment for Photovoltaic Fabrication System"

Table 5 Authorized Activities (or move to Section 7, New Business)

#	Туре	SC/TF/WG	Details
None			

Note: SNARFs and TFOFs are available for review on the SEMI Web site at:

http://downloads.semi.org/web/wstdsbal.nsf/TFOFSNARF





Table 6 New Action Items (or move to Section 8, Action Item Review)

Item #	Assigned to	Details
None		

Table 7 Previous Meeting Actions Items (or move to Section 8, Action item Review)

Iter	n #	Assigned to	Details
None	None		

1 Welcome, Reminders, and Introductions

Makoto Ishikawa (Nisshinbo Mechatronics) called the meeting to order at 10:00. The meeting reminders on antitrust issues, intellectual property issues and holding meetings with international attendance were reviewed. Attendees introduced themselves.

Attachment: 01, 2_Required Elements Reg_20100302_E+J

2 Review of Previous Meeting Minutes

The committee reviewed the minutes of the previous meeting.

Motion: To approve the minutes of the previous meeting as written.

By / 2nd: Terry Asakaw (TEL) / Naoko Murata (TEL)

Discussion: None **Vote:** 4:0

Attachment: 02, TC Mins 071920012 r1

3 Technical Committee Award

The Japan PV Automation Committee gave the Technical Committee Awards to Takashi Murakami (TEL) and Makoto Ishikawa (Nisshinbo Mechatronics).

4 Liaison Reports

4.1 Europe PV Automation Committee

Hirofumi Kanno (SEMI) reported for the Europe PV Automation Committee as following topics.

- Leadership
 - Martin Zenning (Jonas&Redmann Automationstechnik GmbH) stepped down as a co-chair.
- Organization Chart
- Major Activities
 - ➤ Doc 5388 (Revision to SEMI PV34-0712 with Title Change To: Practice for Assigning Identification Numbers to PV Si Brick, Wafer and Solar Cell Manufacturers) and Doc 5418 (Revision of SEMI PV29-0212, Specification for Front Surface Marking of PV Silicon Wafers with Two-Dimensional Matrix Symbols) ballots approved as balloted at SCEU12, pending successful A&R procedural review
 - ➤ 1 SNARF approved at SCEU12:
 - ♦ Revise the scope of doc #5418 by adding a second method to PV29 in the SNARF





- ➤ 1 authorized ballot for cycle 1
- Meeting Information

Attachment: 03, ERSC Liaison Report Nov 2012

4.2 China PC Committee

Hirofumi Kanno (SEMI) reported for the China PV Committee. Of note:

- Leadership (Current Co-chairs): No change
- Organization Chart: No change
- Meeting Information
 - Last meeting:
 - ♦ China Winter Standards Meeting 2012, Wuxi, Jiangsu, China
 - ♦ Saturday, November 3, 2012
 - Next meeting
 - ♦ China Spring Standards Meeting 2013, Shanghai, China
 - ♦ Monday, March 18, 2013 combined with SOLARCON 2013
- Ballots for Cycle1, 2013
 - Doc. 5384, New Standards: Specification for Package protection technology for PV Modules
 - ➤ Doc. 5385, New Standards: Test Method for the content of Vinyl Acetate (VA) in Ethylene-Vinyl Acetate (EVA) applied in PV modules—Thermal Gravimetric Analysis (TGA)
 - Doc. 5428, New Standard: Specification for Impurities in Polyethylene Packaging Materials for Polysilicon Feedstock
 - Doc. 5382, New Standard: Specification for Quasi-monocrystalline Silicon Wafers used in Photovoltaic Solar Cells
- TFs Activities
 - For details, see the attachments.

Attachment: 04, China Photovoltaic Committee Liaison Report20121126

4.3 SEMI Staff Report

Hirofumi Kanno (SEMI) gave the SEMI Staff Report. Of note:

- SEMI global 2012-2013 Calendar of Events
- 2013 Critical Dates for SEMI Standards Ballots
- Regulation SC & A&R SC Reports
- SEMI Standards Publication Reports
- New Standards Ballot and Membership Systems
- New Ballot Formatting Templates
- Style Manual and Compilation of Terms
- Contact Information

Attachment: 05, SEMI Staff Report 2012 December R0.2





5 Subcommittee & Task Force Reports

5.1 PV Transport Carrier Task Force

No update.

5.2 PV Equipment I/F Specification Task Force

Takashi Murakami (TEL) reported for the PV Equipment I/F Specification Task Force. This report contained information on the following topics;

- Task Force Operation
- Current Task Force Activities
- Purpose and scope of #5223
- Ballot Schedule

Motion: To approve distribution of ballot #5223 for Cycle 2, 2013

By / 2nd: Takashi Murakami (TEL) / Naoko Murata (TEL)

Discussion: None **Vote:** 4:0

Attachment: 06, JA PV EIS TF StatusReport20121206r1.0

6 Old Business

6.1 GCS Voter Change

Terry Asakawa(TEL) proposed the GCS voter change. The change was decided among the JA PV Automation committee Co-chairs. Makoto Ishikawa (Nisshinbo Mechatronics) was newly appointed as a GCS voter instead of Emi Ishikawa (Atelier Ishikawa). Terry Asakawa remained as a GCS voter.

6.2 PV Standards Introductory Session

Hirofumi Kanno reported the PV Standards Introductory Session was held in 5th December 11:00-13:00 at Main Stage, Exhibition Hall 9, Makuhari Messe. The agenda for the session was below. It drew more than 60 participants.

- Opening Remarks / Masaaki Yamamichi (AIST)
- Overall Concepts of PV SEMI Standards / Naoko Murata (TEL)
- PV Standards on Materials / Takashi Ishihara (Mitsubishi Electric)
- PV Standards on Equipment Automation / Takashi Murakami (TEL)
- PV Standards on Test Methods and Measurements / Tetsuo Fukuda (AIST)
- Wrap up & Closing Remarks / Masaaki Yamamichi (AIST)

7 New Business

7.1 SEMI Standards Value

Terry Asakawa addressed the committee on this topic and the attendees had discussions about SEMI Standards Value as a Standards Development Organization.





8 Action Item Review

8.1 Open Action Items

None

8.2 New Action Items

None

9 Next Meeting and Adjournment

The next meeting of the Japan PV Automation committee is scheduled for 12th April, 2013 at Japan Standards Spring Meetings 2013 at SEMI Japan Office, Tokyo in Japan.





Respectfully submitted by: Hirofumi Kanno Senior Coordinator SEMI Japan

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Minutes approved by:

Makoto Ishikawa (Nisshinbo Mechatronics), Co-chair	<date approved=""></date>	
Terry Asakawa (TEL), Co-chair	<date approved=""></date>	
Emi Ishikawa (Atelier Ishikawa), Co-chiar	<date approved=""></date>	

Table 8 Index of Available Attachments #1

#	Title	#	Title
01	2_Required Elements Reg_20100302_E+J	_	China Photovoltaic Committee Liaison Report20121126
02	TC Mins_071920012_r1	05	SEMI Staff Report 2012 December R0.2
03	ERSC Liaison Report Nov 2012	06	JA_PV_EIS_TF_StatusReport20121206r1.0

^{#1} Due to file size and delivery issues, attachments must be downloaded separately. A .zip file containing all attachments for these minutes is available at www.semi.org. For additional information or to obtain individual attachments, please contact [SEMI Staff Name] at the contact information above.